

MAIL STOP AMENDMENT  
PATENT  
8075-1099

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Yasuhiko KASAMA et al.

Conf. 9603

Application No. 10/585,245

Group 1792

Filed January 10, 2007

Examiner M. Padgett

ION IMPLANTATION METHOD AND ION IMPLANTATION APPARATUS

**AMENDMENT**

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 31, 2010

Sir:

The following amendments and remarks are respectfully submitted in response to the **non-final** Office Action of March 31, 2010, a period for reply which has been extended two months.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 8 of this paper.